



PATENT APPLICATION
Docket No. 2522-040
Client No. AW8072US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jae-Jong HAN, et al.

Serial No. 10/672,884

Examiner: Lee, Hsien Ming

Confirmation No. 9537

Filed: September 26, 2003

Art Unit: 2823

For: METHOD OF FORMING A GATE ELECTRODE, METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING
THE GATE ELECTRODE, AND METHOD OF OXIDIZING A
SUBSTRATE

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

This paper is responsive to the Office Action mailed on 22 June 2004.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.